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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Yasuyuki MATSUI et al.

USSN: TO BE ASSIGNED - NEW

FILED: October 3, 2005

FOR: Method of Manufacturing Single-Crystal Blocks for Slicing  
off Semiconductor Wafers therefrom

Int. App. No.: PCT/JP2004/010116

Int. App. Filed: July 15, 2004 (15.07.2004)

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COMMISSIONER FOR PATENTS  
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PRELIMINARY AMENDMENT

Dear Sir:

Please amend the above identified patent application as follows.

[AMENDMENT FOLLOWS ON NEXT PAGE]

USPS EXPRESS MAIL  
EV 636 851 726 US  
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